European Network on New Sensing Technologies for Air Pollution Control and Environmental Sustainability - *EuNetAir*

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GRAPHENE GAS SENSORS ENHANCED BY UV LIGHT AND PULSED LASER DEPOSITION



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Motivation

- High potential of graphene responses to single gas molecules have been demonstrated
- For fully exploiting the potential of graphene new approaches are required for increasing the sensitivity in real atmospheric measurements and for making the devices (partially) selective to different target gases
- In the present work, we demonstrate the functionalization of single layer graphene by pulsed laser deposition (PLD) and its impact on the sensing properties to NO₂ gas in case of different deposited materials



University of Tartu



17 500 students1700 academic staff

Founded 1632 by Swedish King Gustav Adolf II





Institute of Physics

New Physicum - 2014

Graphene



- 2D material, 1/2 fully exposed to environment
- High charge carrier mobility (500-10000 cm²V⁻¹s⁻¹ for CVD graphene on substrate), low noise



Detection of single gas molecules



Schedin, A. K. Geim, S. V. Morozov, E. W. Hill, P. Blake, M. I. Katsnelson, K. S. Novoselov, Detection of individual gas molecules adsorbed on graphene, Nat. Mater. 6 (2007) 652-655.

Activation of sensitivity in ambient conditions – O₂



A. Berholts, T. Kahro, A. Floren, H. Alles, R. Jaaniso. Photo-activated oxygen sensitivity of graphene at room temperature. Appl. Phys. Lett. 105, 163111 (2014).

Activation of sensitivity in ambient conditions – NO₂



A. Berholts, T. Kahro, A. Floren, H. Alles, R. Jaaniso. Light-activated gas sensitivity of graphene in ambient conditions. Graphene Week 2014, 23-27 June, Göteburg, Sweden.

Modelling

- Plain graphene:
 - very limited adsorption possibilities
 - small adsorption energies (O_2 0.2 eV, NO_2 0.4 eV)
- Defects and edges
 Doping
 Y. Zou et al. Eur. Phys. J B 81,475, 2011.

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Functionalization by pulsed laser deposition (PLD)



- Target can be any solid material
- Particle kinetic energies can be varied between 0.025 and ~1000 eV
- Typical deposition rates -~1/100th of a monolayer per laser pulse







KrF laser

- 248 nm
- 25 ns
- up to 50 Hz

2 UHV chambers

Process control by ellipsometry and plasma spectrometry



PLD processes in this work

- Sensor structures: lab-grown CVD graphene, transferred onto Si/SiO₂ substrates pre-patterned with Ti/Au electrodes
- Functionalization by PLD process using different deposition targets (ZrO₂ and Ag) ablated by KrF excimer laser.
- The process was carried out in oxygen or nitrogen gas at 5x10⁻² mbar.
- A series of depositions was made with the number of laser pulses 20...2850





Choice of materials



Nanostructured ZrO₂



final layer thickness 14 nm; ~50% pores



Nanostructured Ag



Ag "average" thickness 1nm; particle diameters ~10 nm



Graphene/ZrO₂

NO₂ in air at RT





Effect is especially large at low concentrations



Graphene/Ag

NO₂ in air at RT



- Partial recovery w/o light
- Light enhancement is essential at low concentrations



Why increased sensitivity?

Characterisation:

- SEM
- XPS
- XRF
- Spectrometric ellipsometry
- Conductivity
- Raman spectroscopy



Conductivity







Defect-related lines D and D' emerge and grow with the number of laser pulses N

Why increased sensitivity?

- Large relative response cannot be explained just by decreased conductivity, new adsorption centres should have been formed.
- Ag has much stronger interaction with graphene than ZrO₂. At the same time, it weakens the interaction with NO₂.

• What about other gases?



UV activation of sensitivity to NH₃



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Summary

- PLD can be used to functionalize graphene -> increased AND diversified gas sensitivity
- Mild UV light (365 nm, <1 mW) can activate and enhance gas sensitivity
- Significantly increased sensitivity demonstrated at low NO₂ concentrations, below 100 ppb!



Collaborators and support

Group of Sensor Technologies

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- Artjom Berholts (PhD student)

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